



Form PTO-1449 U.S. Dept. of Commerce, Patent and Trademarks

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Attorney Docket No. CM03351J		Serial No. 09/828,431		Filing Date 4/9/01			
Applicant: Kenneth D. Cornett				Group 2817			
U.S. PATENT DOCUMENTS							
Examiner's Initial		Document No.	Date	Name	Class	Subclass	
	AA						
	AB						
	AC						
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	AE						
	AF						
	AG						
	AH						
FOREIGN PATENT DOCUMENTS							
		Document No.	Date	Country	Class	Subclass	Translation Yes or No
B8	AI	EP 1045 448 A1	10/18/200	EPO			
	AJ						
	AK						
OTHER PRIOR ART (Including Author Title, Date, Pertinent Pages, etc.)							
B8	AL	Wang, Kun et al. VHF Free-Free Beam High Q Micromechanical Resonators. Technical Digest, 12 th International IEEE Micro Electro Mechanical System Conference, Orlando, Florida Jan 17-21, 1999, pp 453-458.					
B8	AM	Wang, Kun et al. VHF Free-Free Beam High Q Micromechanical Resonators. Journal of Microelectromechanical Systems, Vol 9, No. 3 (September 2000), pp 347-359.					
B8	AN	Ayazi, Farrokh et al. High Aspect-Ratio Combined Poly and Single-Crystal Silicon (HARPSS) MEMSS Technology. Journal of Microelectromechanical Systems, Vol, 9, No. 3 (September 2000), pp 288-294.					
EXAMINER Barbara Summons				DATE CONSIDERED: 5/8/03			
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	AI						
	AJ						
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OTHER PRIOR ART (Including Author Title, Date, Pertinent Pages, etc.)

BB	AL	Web page entitled "New Developments in Canon ELTRAN SOI Wafer Technology, http://www.usa.canon.com/indtech/semicondeq/news_developments.html , printed 3/21/01 (6 pages).
BB	AM	Flandre, Denis, Colinge, Jean Pierre, Status and Trends of SOI, http://www.dice.ucl.ac.be/%7EFlandre/ESSCIRC94/ESSCIRC94.html , printed 3/21/01 (11 pages).
BB	AN	Goselle, U., Tong, Q.Y., Science and Technology of Semiconductor Wafer Bonding (Tentative), Chapter 7, http://www.duke.edu/web/wbl/ch7/ch7-hpge.html , printed 3/20/01 (28 pages) [Table of Contents, 11 pages].

EXAMINER

Paula Summora

DATE CONSIDERED:

5/8/03

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